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Substitute Form PTO-1449 U.S. Department of Commerce (Modified) Patent and Trademark Office			•	Application No New Appl				
Information Disclosure Statement by Applicant			Applicant Hajime KIMURA					
	(Use sev	eral sheets if neces	sary)	Filing Date			Group Art Unit	
(37 CFR §1.98	(b))		II O D-4-	May 8, 2001		287	<u>y</u>	9862 62
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721	AL	JP 9-219823	 	JAPAN	Giaso	Cabolado	X	.,,
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Other Documents (include Author, Title, Date, and Place of Publication)			
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Initial	1D	Document	
AXV	AQ	Yamaguchi, M. et al., "Two-Dimensional Contact-Type Image Sensor Using Amorphous Silicon Photo-Transistor", Japanese Journal of Applied Physics, vol. 32, No. 1B, Jan. 1993, pp. 458-461.	
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